

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

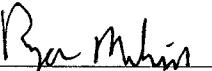
Applicant : Wen-Jian Lin
Appl. No. : 10/810,660
Filed : Marych 29, 2004
For : STRUCTURE OF A MICRO
ELECTRO MECHANICAL
SYSTEM AND THE
MANUFACTURING METHOD
THEREOF
Examiner : Jarrett J. Stark
Group Art Unit : 2823

**CERTIFICATE OF EFS WEB
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I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

May 17, 2007

(Date)



Ryan E. Melnick, Reg. No. 58,621

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed March 22, 2007, please find the enclosed remarks.

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.